

THIRD
INFORMATION DISCLOSURE
STATEMENT BY APPLICANT
 (use as many sheets as necessary)

Sheet 1 of 1

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| Application Number | 10/593,266 |
| Filing Date | September 18, 2006 |
| First Named Inventor | Satoru Banzai |
| Examiner Name | Christopher M. Pochas |
| Attorney Docket No. | 1009682-000163 |

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*Enter Office that issued the document, by the two-letter code.

NON-PATENT LITERATURE DOCUMENTS

| Examiner Initials | Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published. |
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| Examiner Signature | /Christopher Pochas/ | Date Considered | 05/13/2009 |
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /C.P./